

REMARKS

Claims 1, 4, 9, 10 and 17-19 are pending in this application.

By this Amendment, claim 1 is amended to incorporate the subject matter of claims 2, 3 and 5 and to further clarify the subject matter therein, claim 4 is amended to change its dependency from claim 3 to claim 1, claim 17 is amended to depend from claim 1 and to remove duplicative subject matter, claims 2, 3, 5, 11 and 16 are canceled, and claims 18 and 19 are added. No new matter is added by this Amendment. Support for the amendments to the claims can be found in the original specification, claims and figures. In particular, support for the amendment to claim 1 may be found in original claims 2, 3 and 5, as well as at paragraph [0042] of the specification. Support for new claim 18 may be found in Fig. 4. Support for new claim 19 is found in original claim 17.

I. Allowable Subject Matter

Applicant thanks the Examiner for the indication that claim 9 is allowed.

II. Rejection Under 35 U.S.C. §102

Claims 1-5, 10, 11, 16 and 17 are rejected under 35 U.S.C. §102 over Japanese Laid-Open Application No. 11-97699 (Shigeki). This rejection is respectfully traversed.

Claims 2, 3, 5, 11 and 16 are canceled. Thus, with respect to claims 2, 3, 5, 11 and 16, this rejection is moot.

Claim 1 recites that the sub gate electrode is extended past the semiconductor film.

Shigeki discloses a sub gate electrode. However, Shigeki fails to teach or suggest that the sub gate electrode is extended past the semiconductor film.

New claim 18 recites that the sub gate electrode is disposed so as to cover the gate electrode.

Shigeki fails to teach or suggest that the sub gate electrode is disposed so as to cover the gate electrode.

Accordingly, Shigeki fails to disclose the subject matter of claims 1 and 18. Claims 1 and 18, as well as the claims dependent therefrom, are thus not anticipated by Shigeki and are in condition for allowance.


Withdrawal of the rejection is respectfully requested.

III. Conclusion

In view of the foregoing, it is respectfully submitted that this application is in condition for allowance. Favorable reconsideration and prompt allowance of the pending claims are earnestly solicited.

Should the Examiner believe that anything further would be desirable in order to place this application in even better condition for allowance, the Examiner is invited to contact the undersigned at the telephone number set forth below.

Respectfully submitted,



James A. Oliff
Registration No. 27,075

Linda M. Saltiel
Registration No. 51,122

JAO:LMS/djb

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OLIFF & BERRIDGE, PLC
P.O. Box 19928
Alexandria, Virginia 22320
Telephone: (703) 836-6400

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